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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tsuneo KAGOTANI et al.

Group Art Unit: 1756

Application No.: 10/643,917

Examiner: J. MCPHERSON

Filed: August 20, 2003

Docket No.: 116900

For: MAGNETO-RESISTANCE EFFECT ELEMENT BAR EXPOSURE METHOD (AS AMENDED)

**AMENDMENT UNDER 37 C.F.R. §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 28, 2006 Office Action, please consider the following:

**Amendments to the Specification;**

**Amendments to the Drawings** include an attached replacement sheet;

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**